Contribution ID: 8 Type: MCRP-M

## Clarification of the relationship between SiC/SiO2 interface structures and electronic properties

Number of project members 5 Cygnus: Project code [No] Cygnus: Requested [awarded] number of nodes [0] Cygnus: Requested [awarded] node-hour product [0] Cygnus: Requested [awarded] disk capacity (TB) OFP: Project code [xg19i063] OFP: Requested [awarded] number of nodes [1024]OFP: Requested [awarded] node-hour product 300000 [213333] OFP: Requested [awarded] disk capacity (TB) [20]

 $Primary\ author(s):\ \ MATSUSHITA,\ Yu\mbox{-ichiro}\ (Tokyo\ Institute\ of\ Technology)$ 

Track Classification: Material Science(物質科学分野)